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To:	Examiner E.J. Kielin Group Art Unit: 2813	From:	Leslie S. Szivos, Ph.D.
Fax:	703-872-9306	Pages:	14 including cover
Phone:		Date:	October 26, 2004
Re:	Jack O. Chu, et al. U.S. Patent Appln. No. 09/692,606 Our Docket: 17178	CC:	

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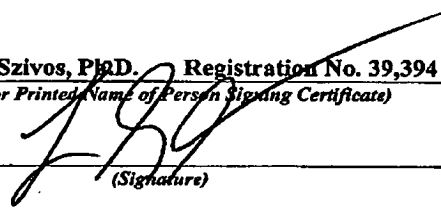
Dear Sir:

The following is attached hereto:


1. Response Under 37 C.F.R. §1.111
2. Amendment Transmittal
3. Authorization to charge deposit acct. no. 50-0510/IBM
4. Certificate of Facsimile

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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No.	
Applicant(s): Jack O. Chu, et al.			YOR920000344US1 (17178)	
Application No. 09/692,606	Filing Date 10/19/2000	Examiner E.J. Kielin	Group Art Unit 2813	
Invention: LAYER TRANSFER OF LOW DEFECT SiGe USING AN ETCH-BACK PROCESS				
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<p>I hereby certify that this _____ Response Under 37 C.F.R. §1.111 _____ (Identify type of correspondence)</p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9306</u>)</p> <p>on <u>October 26, 2004</u> (Date)</p> <p style="text-align: center;"><u>Leslie S. Szivos, Ph.D.</u> Registration No. 39,394 (Typed or Printed Name of Person Signing Certificate)</p> <p style="text-align: center;"> (Signature)</p>				
Note: Each paper must have its own certificate of mailing.				

P18/REV02

AMENDMENT TRANSMITTAL LETTER (Large Entity)				Docket No. YOR92000344US1 (17178)	
Applicant(s): Jack O. Chu, et al.					
Application No. 09/692,606	Filing Date 10/19/2000	Examiner E.J. Kielin	Customer No. 23389	Group Art Unit 2813	Confirmation No. 7913
Invention: LAYER TRANSFER OF LOW DEFECT SiGe USING AN ETCH-BACK PROCESS					
<u>COMMISSIONER FOR PATENTS:</u>					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	40 -	42 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	3 -	3 =	0 x	\$86.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00
 <input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 50-0510/IBM <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17. <div style="display: flex; justify-content: space-between; align-items: flex-end;"><div style="text-align: center;"> _____ <i>Signature</i> Leslie S. Szivos, Ph.D. Registration No. 39,394 Customer Number: 23389</div><div style="text-align: right;">Dated: October 26, 2004</div></div>					
<div style="border: 1px solid black; padding: 5px; width: fit-content;"><p>I certify that this document and fee is being deposited on _____ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.</p><p>_____ <i>Signature of Person Mailing Correspondence</i></p><p>_____ <i>Typed or Printed Name of Person Mailing Correspondence</i></p></div>					
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P11LARGE/REV07

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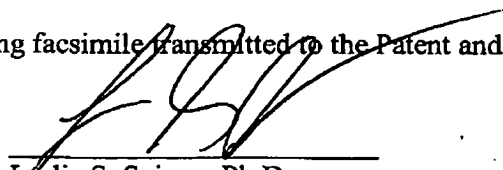
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**Applicant(s):** Jack O. Chu, et al.**Examiner:** E.J. Kielin**Serial No.:** 09/692,606**Art Unit:** 2813**Filed:** October 19, 2000**Docket:** YOR920000344US1 (17178)**For:** LAYER TRANSFER OF LOW DEFECT
SiGe USING AN ETCH-BACK PROCESS**Dated:** October 26, 2004**Confirmation No.** 7913Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**RESPONSE UNDER 37 C.F.R. § 1.111**

Sir:

In response to the Office Action dated July 26, 2004, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: October 26, 2004

Leslie S. Szivos, Ph.D.